

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor: Jeffrey W. Carr

Appln. No.: 10/608,384

Confirm. No.: 7970

Filed: June 27, 2003

Title: APPARATUS AND METHOD FOR REACTIVE
ATOM PLASMA PROCESSING FOR
MATERIAL DEPOSITION

PATENT APPLICATION

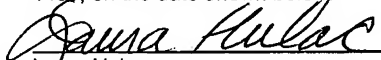
Art Unit: 1765

Examiner: Vinh, L.

Customer No. 23910

CERTIFICATE OF MAILING UNDER 37 CFR § 1.8

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Art Unit 1711, Commissioner for Patents, Alexandria, VA 22313-1450, on the date shown below.



(Signature)

Laura Hulac

Signature Date: 7-28-05

REPLY TO OFFICE ACTION UNDER 37 CFR § 1.111

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

This Reply is in response to the Office Action dated February 1, 2005.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.